



PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
HAUBRICH, et al

Application No.: 10/666,912

Filed: September 19, 2003

For: PROCESS FOR FORMING A
PATTERNED THIN FILM STRUCTURE
ON A SUBSTRATE

Atty. Docket No.: SIPXP054C1

Examiner: Unassigned

Group: 1762

Date: January 16, 2004

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop _____, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on January 19, 2004.

Signed: _____

Pat Tate
Pat Tate

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§1.56 AND 1.97(b) BEFORE MAILING OF A FIRST OFFICE ACTION

Mail Stop _____
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449 may be material to examination of the above-identified patent application. Applicants submit the list of these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application. Because the above-identified patent application was filed after June 30, 2003, copies are attached only of those listed

references, if any, that are not either a U.S. patent or U.S. patent application publication. Applicants submit that copies of the U.S. patent and/or U.S. patent application publication references listed, if any, need not be provided pursuant to the notice published in the Official Gazette at 1274 Off. Gaz. Pat. Off. 55, 8/5/2003.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 50-0685 (Order No. SIPXP054C1).

Respectfully submitted,
VAN PELT & YI LLP



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Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No. SIPXP054C1 Application No.: 10/666,912 Inventor HAUBRICH, et al Group 1762 Filing Date September 19, 2003
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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A	6,080,606	June 27, 2000	Gleskova, et al	438	151	Mar. 26, 1996
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	L	03 084521	10/04/91	Japan	G02F	1/1343		No
	M	09 254 332	09/30/97	Japan	B22B	27/08		No
	N	0 390 465	10/03/90	Europe	G03F	7/004	Yes	
	O	02/01281	01/03/02	WO	G02F	1/00	Yes	
	P							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	R	
	S	
	T	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.